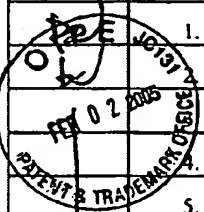


Form PTO-1449		U.S. Department of Commerce Patent and Trademark Office			Attorney Docket No. 5308-394		Serial No. 10/811,350	
LIST OF DOCUMENTS CITED BY APPLICANT (Use several sheets if necessary)					Applicant: Gerald H. Negley		Filing Date: March 26, 2004	
							GAU: 2812	
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Examiner Initials	Document No.	Date (m/d/y)	Name	Class	Subclass	Filing Date if Appropriate		
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20.	Pearlton, S.J., "Wet and Dry Etching of SiC," <i>Process Technology for Silicon Carbide Devices</i> , pp. 85-92. Ch. 4 (2002).							

Examiner:



Date Considered:

8/2/06

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